



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Satoshi INOUE et al.

Group Art Unit: 2812

Application No.: 10/748,206

Examiner: R. BOOTH

Filed: December 31, 2003

Docket No.: 040852.98

For: MANUFACTURING METHOD OF ACTIVE MATRIX SUBSTRATE, ACTIVE
MATRIX SUBSTRATE AND LIQUID CRYSTAL DISPLAY DEVICE

CONFIRMATION OF TELEPHONE CONFERENCE WITH EXAMINER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the February 10, 2006 Office communication, we have now conducted a telephone interview with Examiner Booth on January 23 regarding the Information Disclosure Statement (IDS) filed on January 6, 2006.

Examiner Booth acknowledged that reference 1 (WO-92/12453) corresponds to reference 2 (JP-A-06-504139), as stated on page 2 of the IDS. Accordingly, Applicants assert that the aforementioned acknowledgement satisfies the 2 month shortened statutory period for reply to the Requirement for Information, and hence no further response is required from Applicants. Thus, Applicants respectfully request that the Examiner withdraw the Requirement for Information.

Furthermore, Applicants respectfully request that the information submitted with the January 6, 2006 IDS be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

Respectfully submitted,

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JAO:BAZ/hs

Date: February 24, 2006

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